

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1756 Examiner: Kathleen Duda

in Re PATEN	I APPLICATION OF:	MEC.
Applicant	: Minoru WATANABE	) JUL 15 PED
Appln. No.	: 10/025,783	MECEIVED  JUL 15 2003  TC 1700
Filed	: December 26, 2001	) AMENDMENT
For	: METHOD AND APPARATUS FOR FORMING RESIST PATTERN	) AMENDMENT ) )
Attorney Ref.	: MAE 223 C1	) )

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Amendment is submitted with the Applicant's Request for Continued Examination pursuant to 37 C.F.R. §1.114(a). Please amend the above-referenced application as follows:

## **IN THE CLAIMS**

Please cancel claims 8-9, 12, 21-22 and 25 without prejudice or disclaimer to the subject matter recited therein. Please amend claims 1, 10-11, 13, 17, 23-24, 26 and 31-32, and add new claims 33-38, as shown in the listing of claims beginning on the next page under the heading **Amendments to the Claims**.